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Patent Application
ATM-515 (7486)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: XU, Chongying, et al.

Application No.: 10/015,326

Date Filed: December 13, 2001

Title: METHOD FOR REMOVAL
OF IMPURITIES IN CYCLIC
SILOXANES USEFUL AS
PRECURSORS FOR LOW
DIELECTRIC CONSTANT
THIN FILMS

Docket No.: ATMI-515 (7486)

Examiner: Virginia MANOHARAN

Art Group: 1764

Confirm. No.: 2946

Customer No.:

25559

FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Virginia MANOHARAN

Fax No.: (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on July 25, 2005, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300

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Number of Pages (including cover)

Marianne Fuierer
Marianne Fuierer

July 25, 2005

Date

**RESPONSE TO MAY 25, 2005 OFFICE ACTION
IN UNITED STATES PATENT APPLICATION NO. 10/015,326**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the May 25, 2005 Office Action, please amend the application as follows: